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** CONTINUING DATA *NONE PD*

** FOREIGN APPLICATIONS *NONE PD*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
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Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY IRELAND	SHEETS DRAWING 6	TOTAL CLAIMS 49	INDEPENDENT CLAIMS 3
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Verified and Acknowledged *[Signature]* *PD*
 Examiner's Signature Initials

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TITLE
 Method for forming a cavity and an SOI in a semiconductor substrate, and a semiconductor substrate having a buried cavity and/or an SOI formed therein

FILING FEE RECEIVED	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
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